



AP/ITM

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Shun-ichi FUKUYAMA et al.**

Group Art Unit: 2813

Serial No.: 10/630,716

Examiner: Stephen W. Smoot

Filed: July 31, 2003

Confirmation No.: 9374

For: **SEMICONDUCTOR DEVICE USING LOW-K MATERIAL AS
INTERLAYER INSULATING FILM AND ITS MANUFACTURE
METHOD**

Attorney Docket Number: 030860

Customer Number: 38834

O.K.
to
Enter
S.W.S.
5-14-05

SECOND AMENDMENT AFTER FINAL REJECTION

MAIL STOP AF

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: May 11, 2005

Sir:

This paper is filed in response to the Advisory Action dated May 4, 2005.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.